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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Sang Ick LEE et al.]

Serial No.: 09/994,284]

Filed: 26 November 2001]

For: METHOD OF FORMING METAL]
GATE IN SEMICONDUCTOR]
DEVICE]

Group Art Unit: 2823

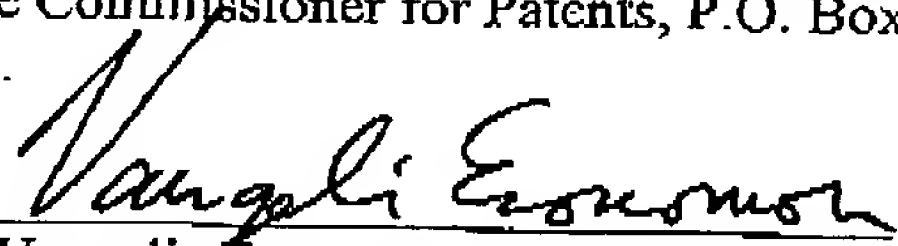
Examiner: Pham, Thanh V.

JAN 07 2004

OFFICIAL

AMENDMENT AFTER FINALCertification under 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being transmitted by facsimile to the United States Patent and Trademark Office at the following facsimile number: (703) 872-9306, to the attention of Examiner Pham, and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 7, 2004.


Vangelis Economou, Reg. No. 32,341

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AMENDMENT UNDER 37 C.F.R. § 1.116

Sir:

In response to the Office Action dated October 7, 2003, please consider the following remarks in the above-identified application.